

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Jiong-Ping Lu et al.	Docket No.:	TI-35669
Serial No.:	10/722,013	Examiner:	Erdem, F.
Filing Date:	11/25/2003	Art Unit:	2826
Customer No.:	23494	Conf. No.:	6979

Title: A CAPACITOR FORMED ON A RECRYSTALLIZED POLYSILICON LAYER
AND A METHOD OF MANUFACTURE THEREFOR

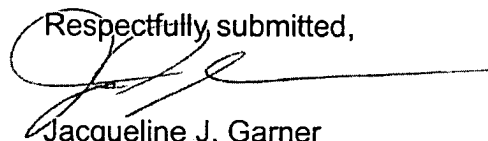
ELECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

With respect to the Restriction Requirement mailed on 01/04/2008, the Examiner required restriction between Group I (Claims 2-5, 7, 8 and 19-21) and Group II (Claims 9, 10 and 12-18). Applicants hereby elect Group I (Claims 2-5, 7, 8 and 19-21).

Respectfully submitted,



Jacqueline J. Garner
Attorney for Applicants
Reg. No. 36,144

Texas Instruments Incorporated
P.O. Box 655474, M/S 3999
Dallas, TX 75265
(214) 532-9348 or
(972) 917-5643
Fax: (972) 917-4418